

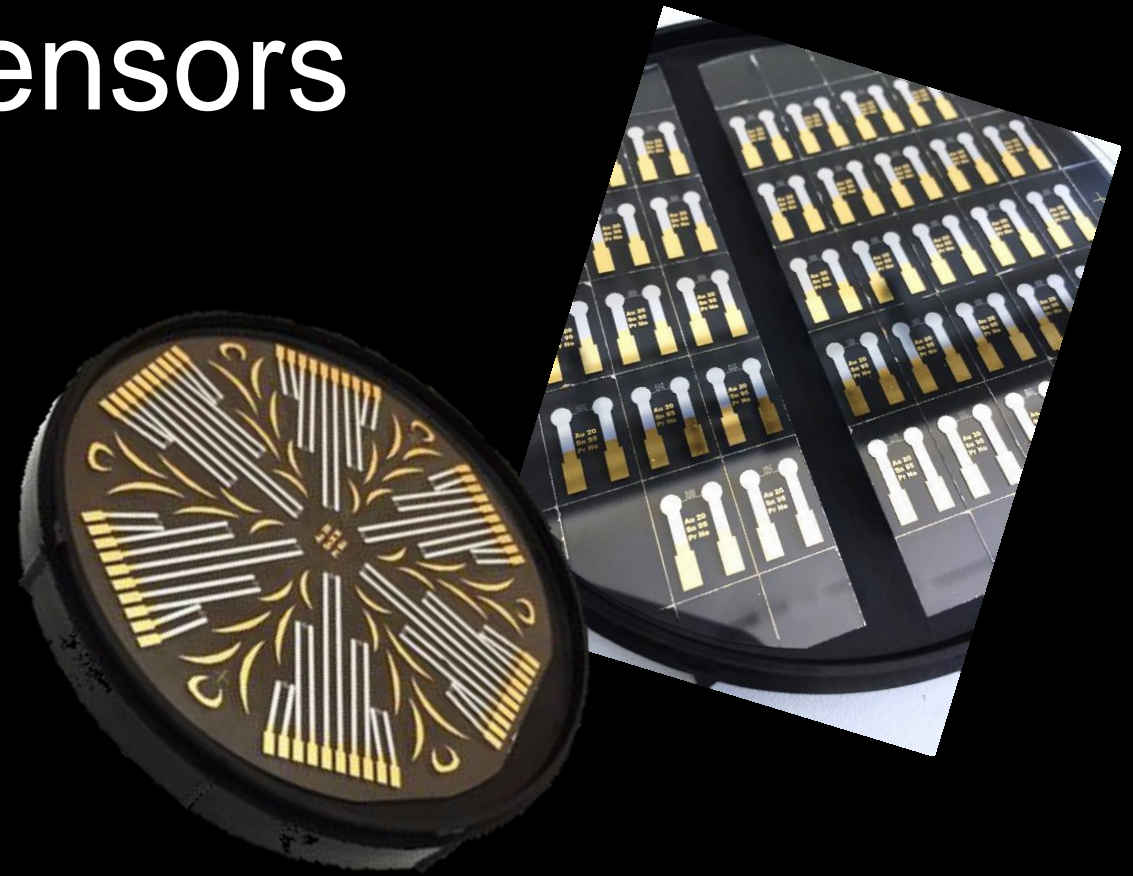
Helium II second sound detection, heat source localisation (and more...) with transition edge sensors

Hernán Furci hernan.furci@cern.ch

Tobias Stegmaier, Torsten Koettig, Giovanna Vandoni

ICEC 2018 – Oxford, UK – September 2018

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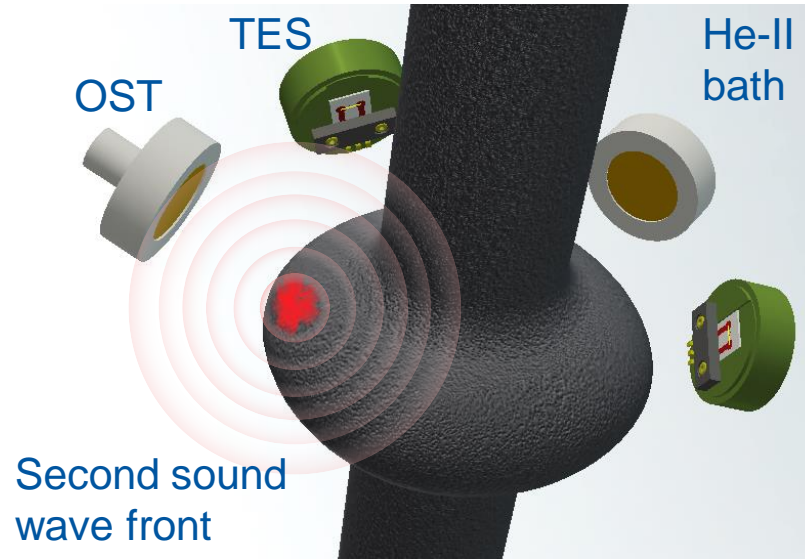
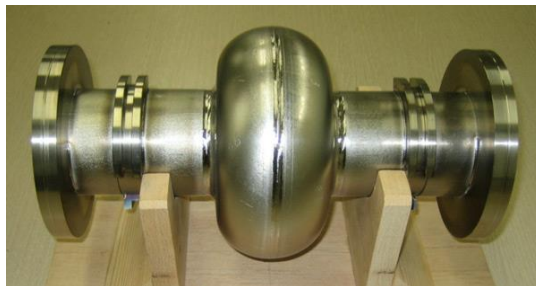
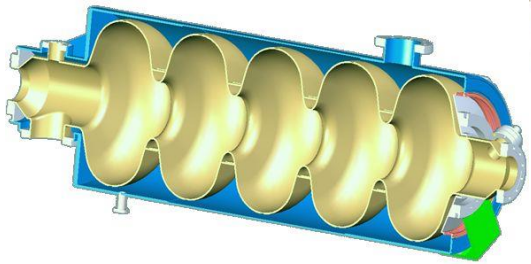
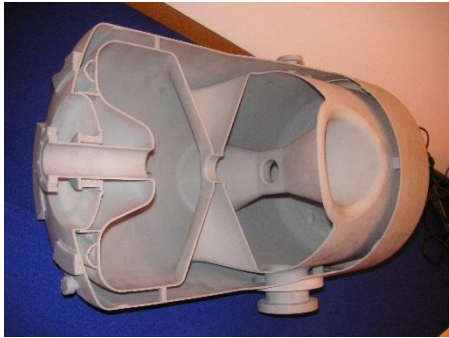


Context

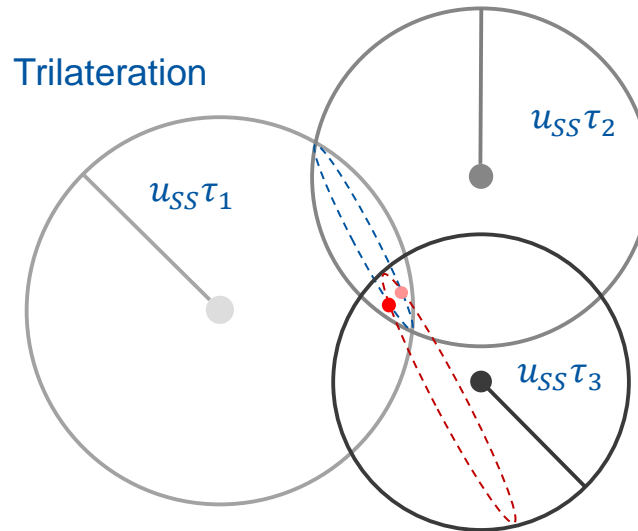
SRF cavities non-contact thermal mapping

Transition edge sensors

Non contact SRF hotspots localization



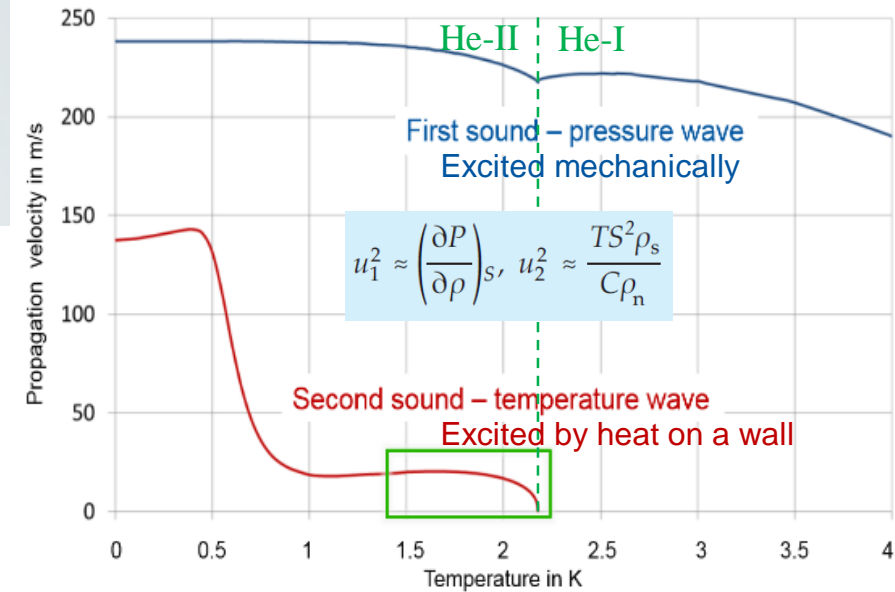
Second sound wave front



Trilateration

Second sound source:

$$\Delta T_{SS} \propto \frac{1}{\rho C u_{SS}} \frac{\partial q''}{\partial t}$$

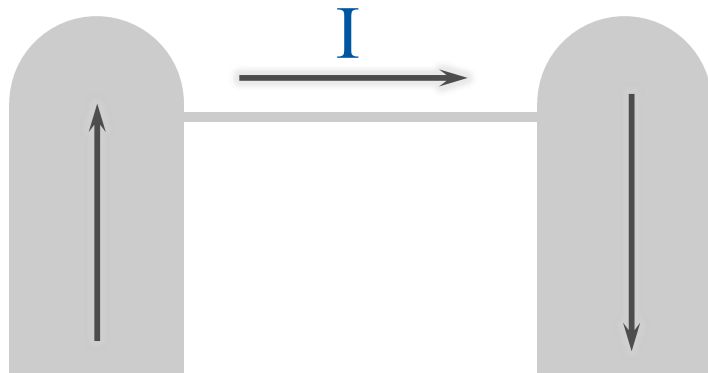
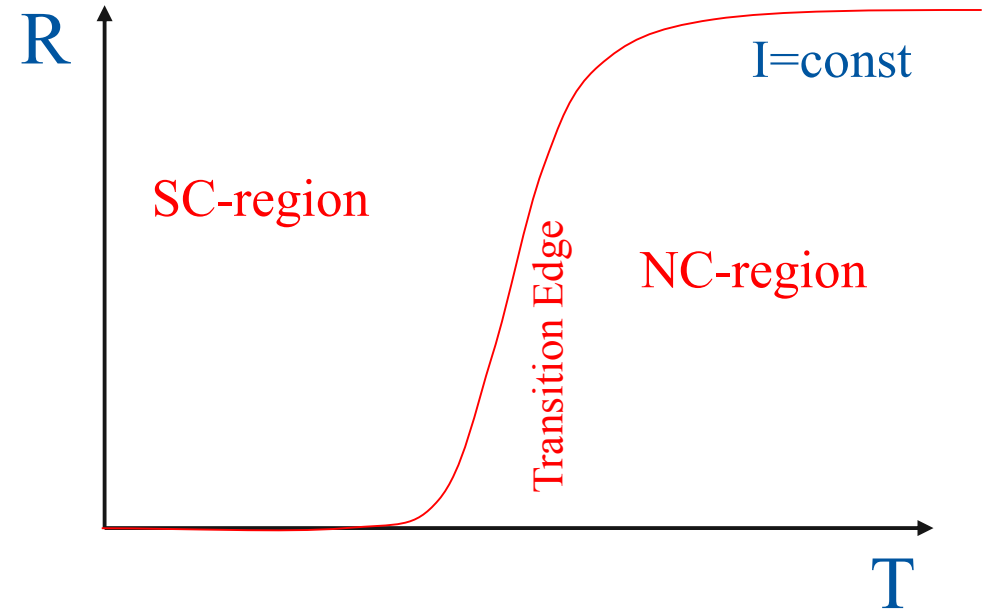


Transition Edge Sensors

Bolometers: tiny and fast temperature variations
(≈ 1 mK, sub-ms range)

Gradual SC to NC transition of thin film alloy

Only sensitive in the transition range



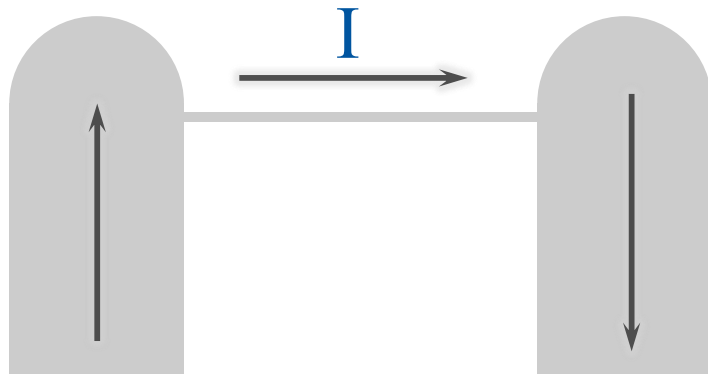
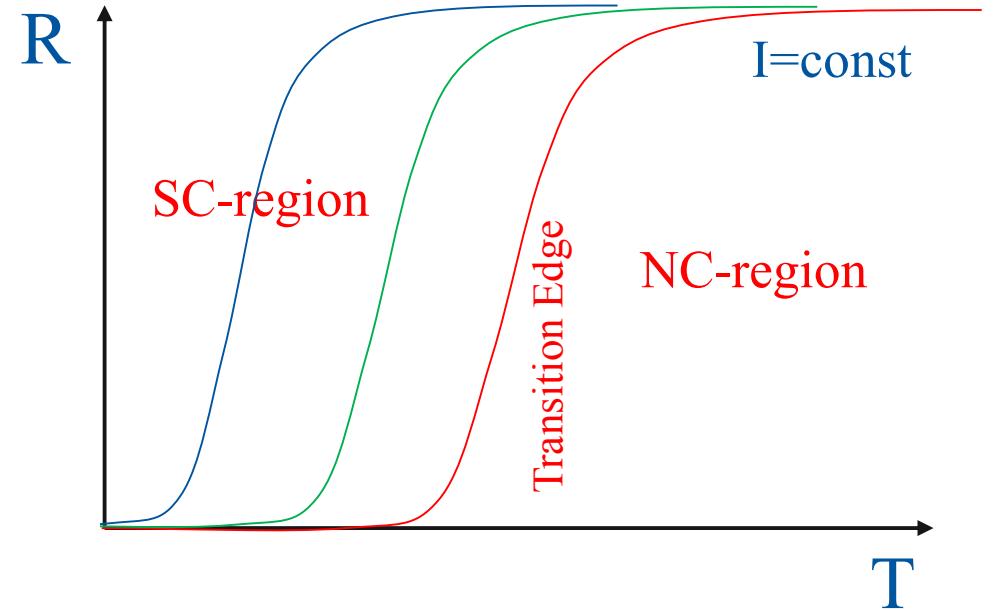
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Transition range 'tuned' with a bias current



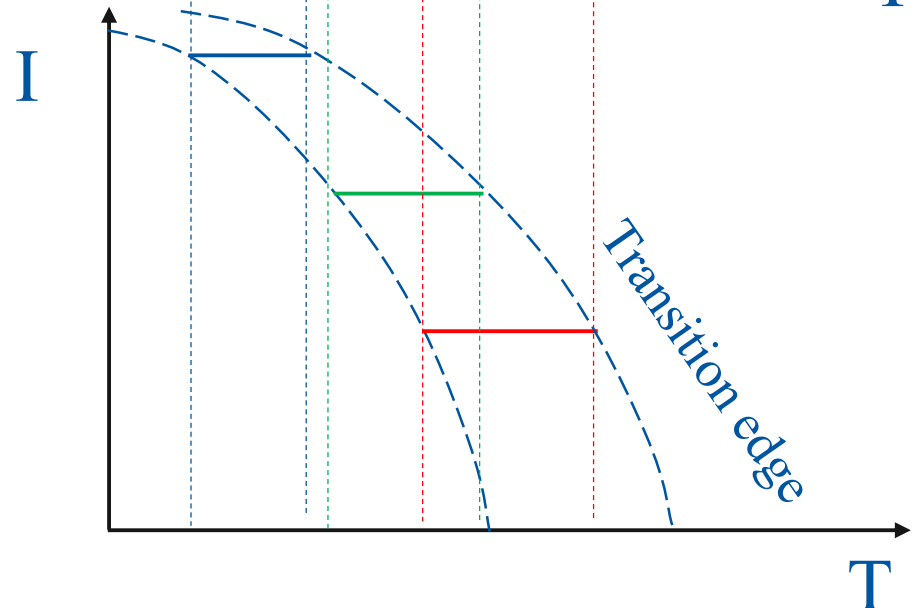
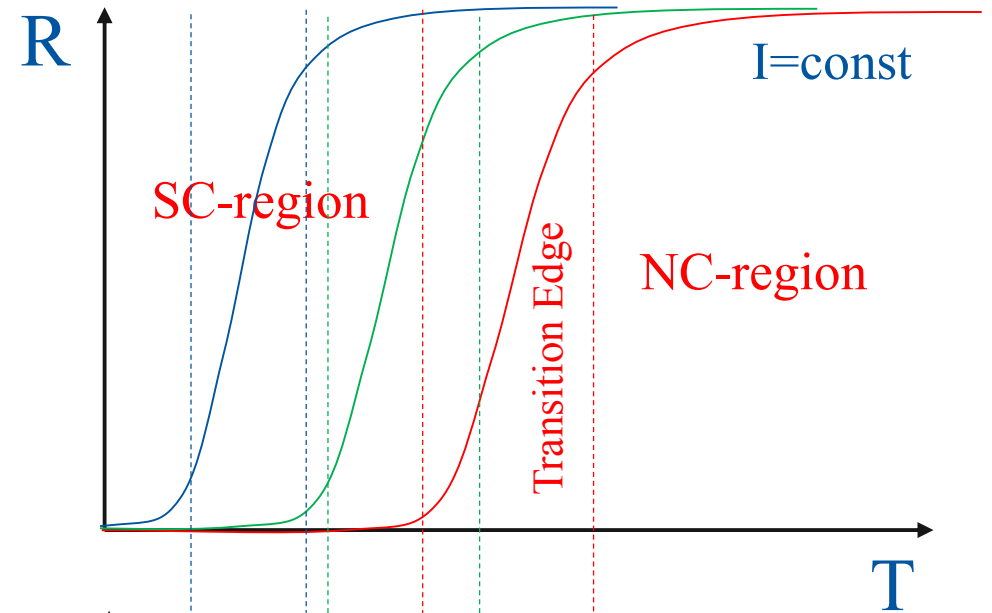
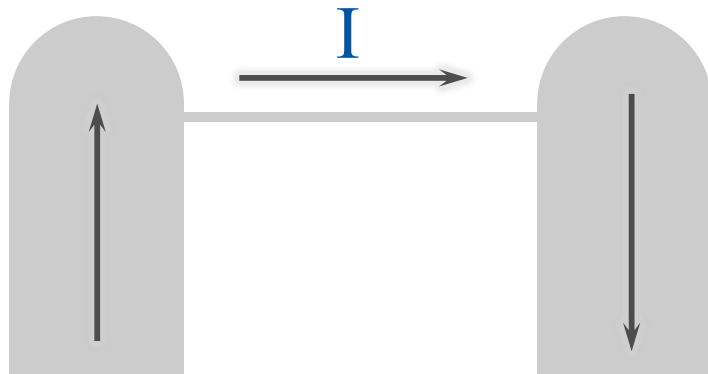
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TES development at CERN

Fabrication, designs, characteristics

TES fabrication process developed at CERN

2 Lift-off-based processes with different deposition method

Process description	Cross-section
<i>Coating positive resist</i>	
<i>LASER Writing Direct</i>	
<i>Developing</i>	
<i>Metal Deposition</i>	
<i>Evaporation</i> <i>Sputtering</i>	
<i>Lift-off with solvents</i>	

The lift-off step takes around two days.

Etching-based process

Process description	Cross-section
<i>Metal deposition</i> <i>Sputtering</i>	
<i>Coating positive resist</i>	
<i>LASER Writing Inverted</i>	
<i>Developing</i>	
<i>Ion Beam Etching</i>	
<i>Resist stripping</i>	

This process can be achieved in 4 hours.

Both processes have been fully specified and mastered to obtain good sensors.

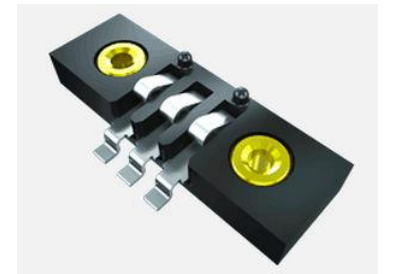
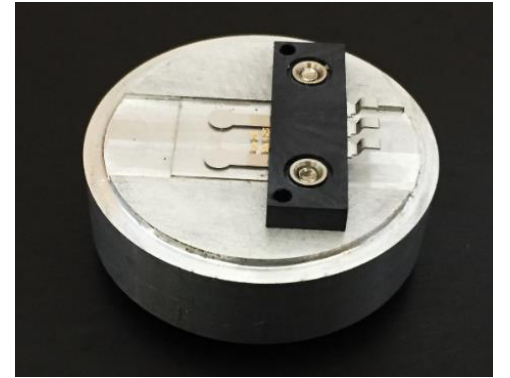


TES designs

Camera-like device

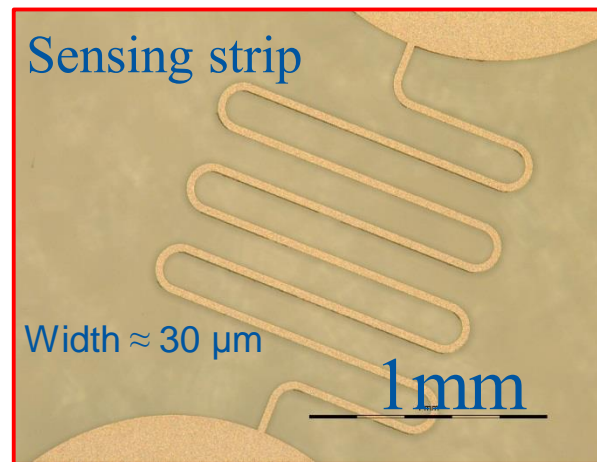
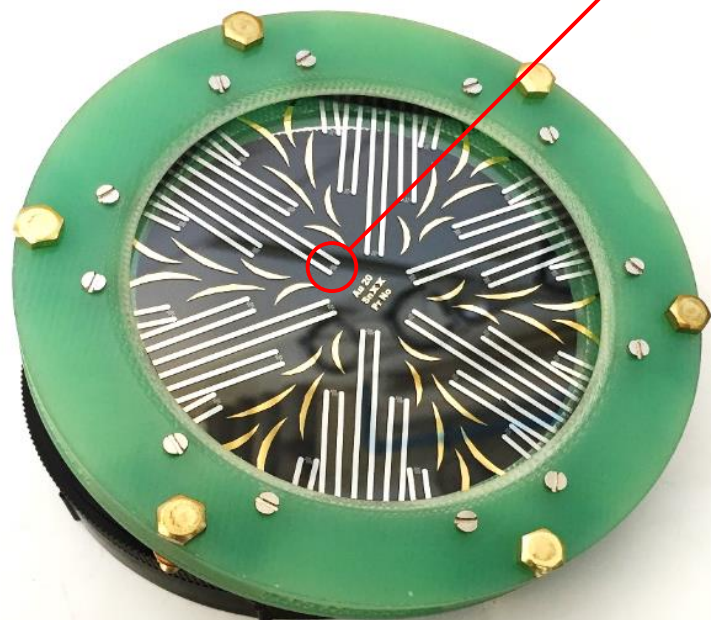


Individual chips

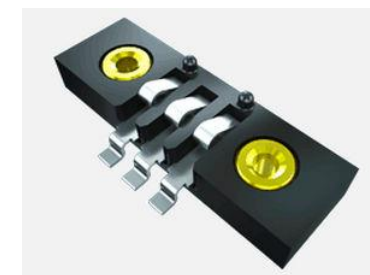
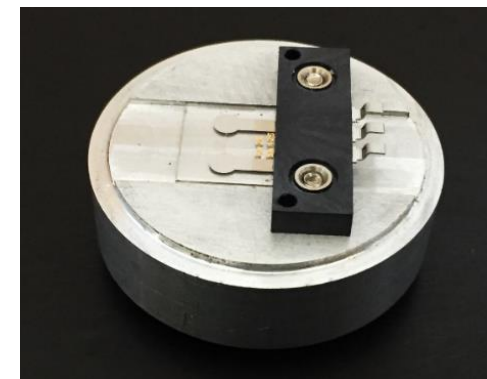


TES designs

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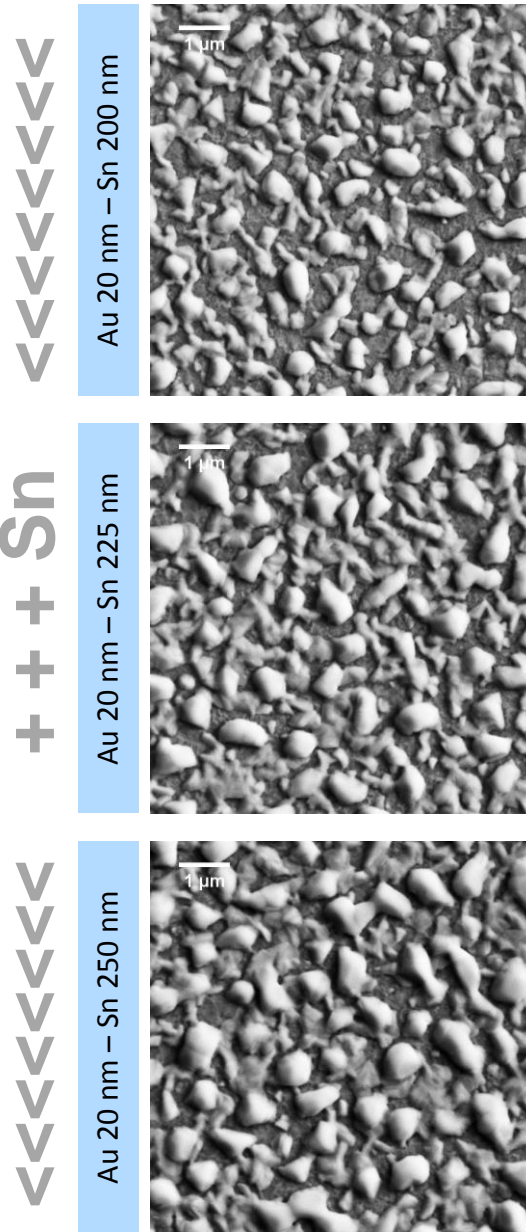


TES properties

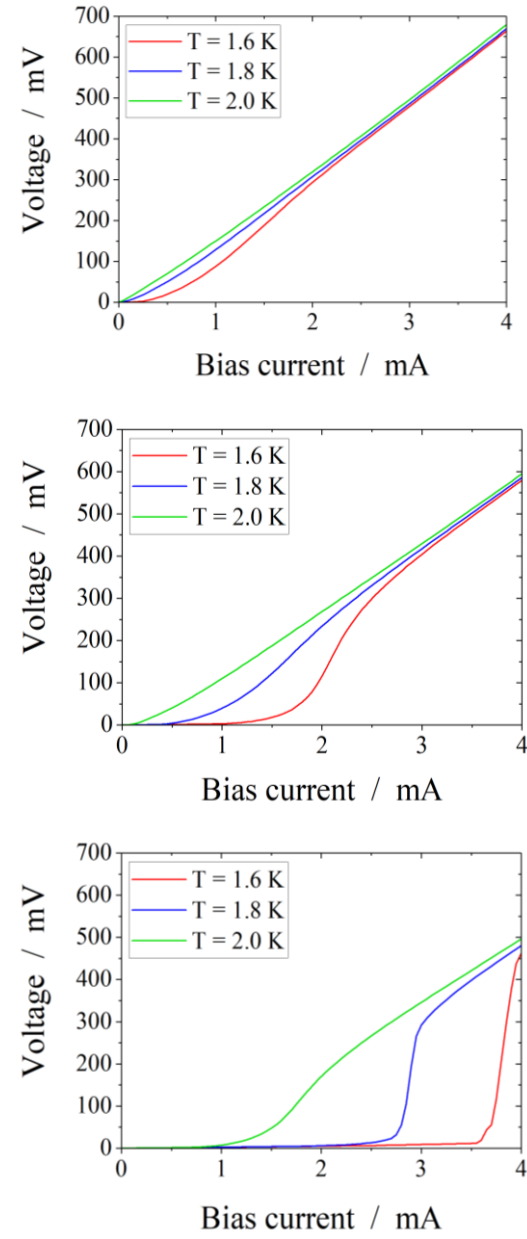
- Au-Sn TES thin films are inhomogeneous
- Sn-rich features lay on a Sn-poorer matrix
- Transition behaviour extremely sensitive to Sn content
- SC behaviour ruled by inter-feature distance?
- The thermal history of the thin film is crucial

For more info, come and see
POSTER M-09: 164

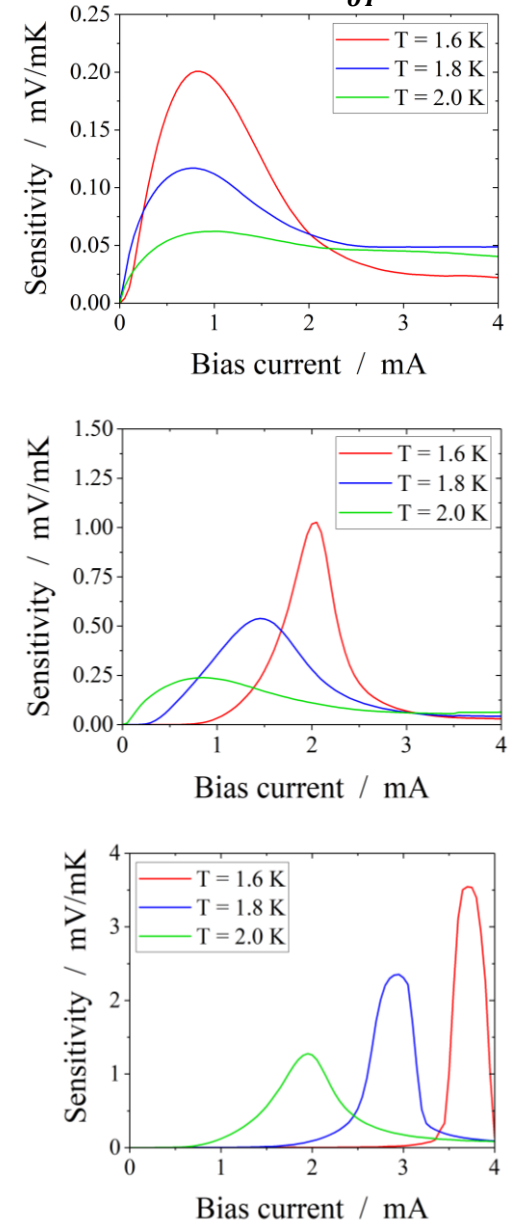
Microstructure (SEM)



$V(I, T)$ collected data



Thermal sensitivity $\frac{\partial V}{\partial T}(I, T)$



Second sound experiments with TES

Second sound speed

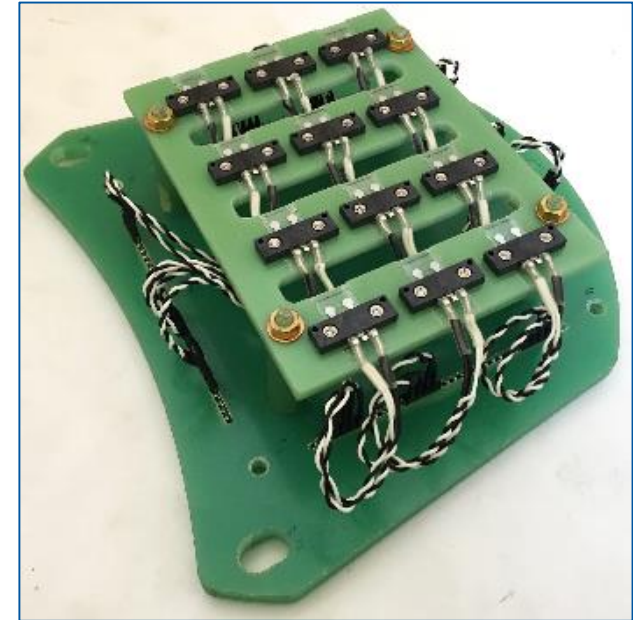
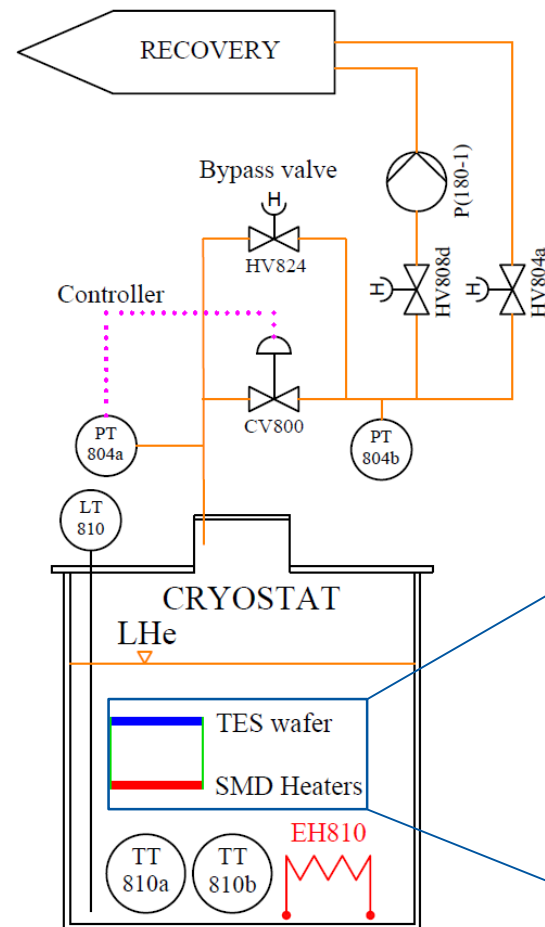
Localisation of small heat sources

Second sound intensity distribution

Extended heat sources

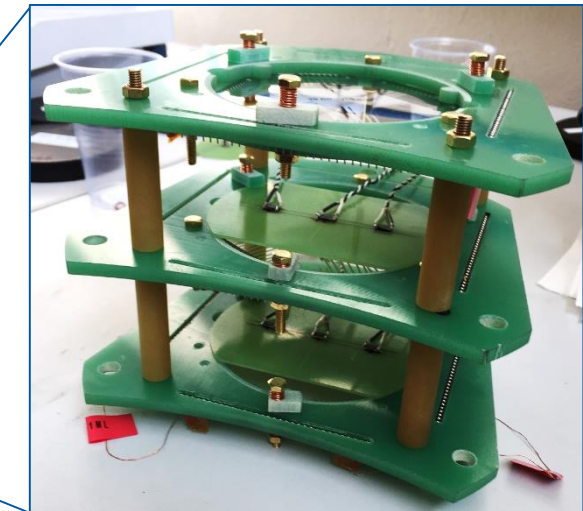
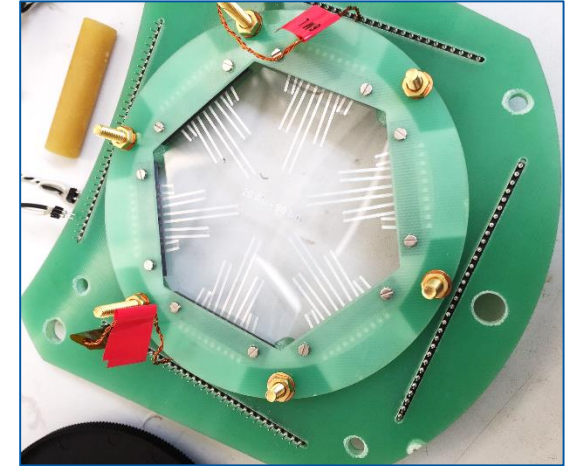
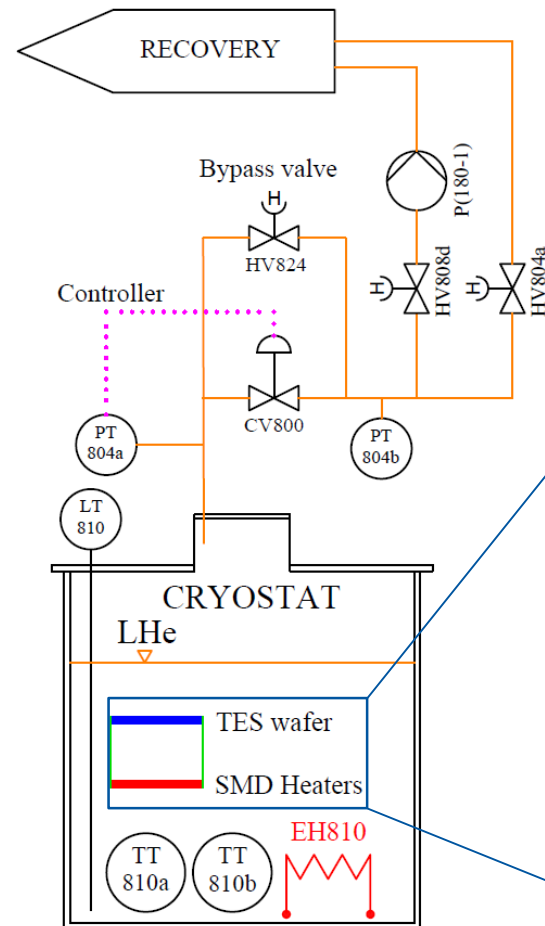
Second sound tests setup at the Cryolab

- Saturated superfluid helium ($T = 1.6 - 2.1$ K)
- TES are biased with a variable current regulated source
- SMD heaters imitate quench spot
- DAQ and heater control
NI, up to 100 kHz, 24 bits in 3 V range



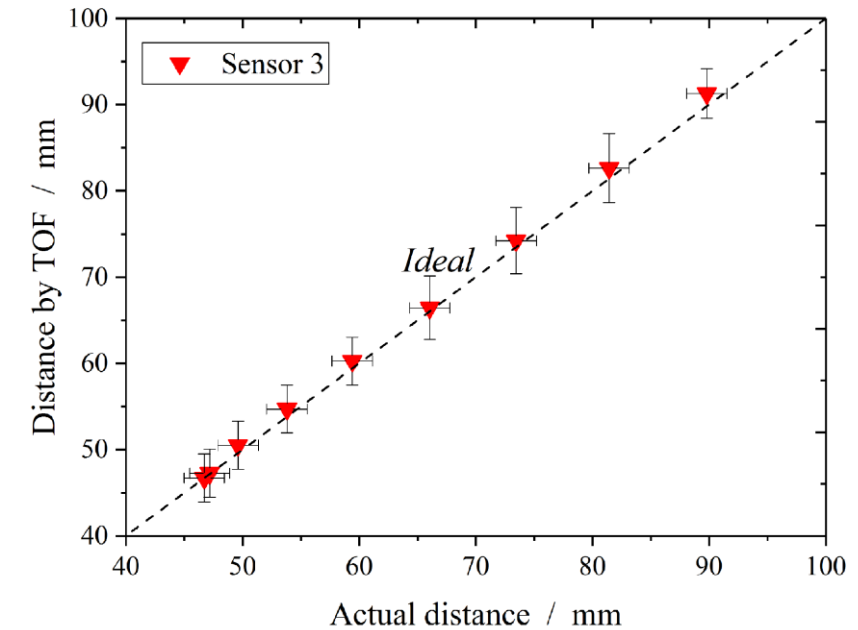
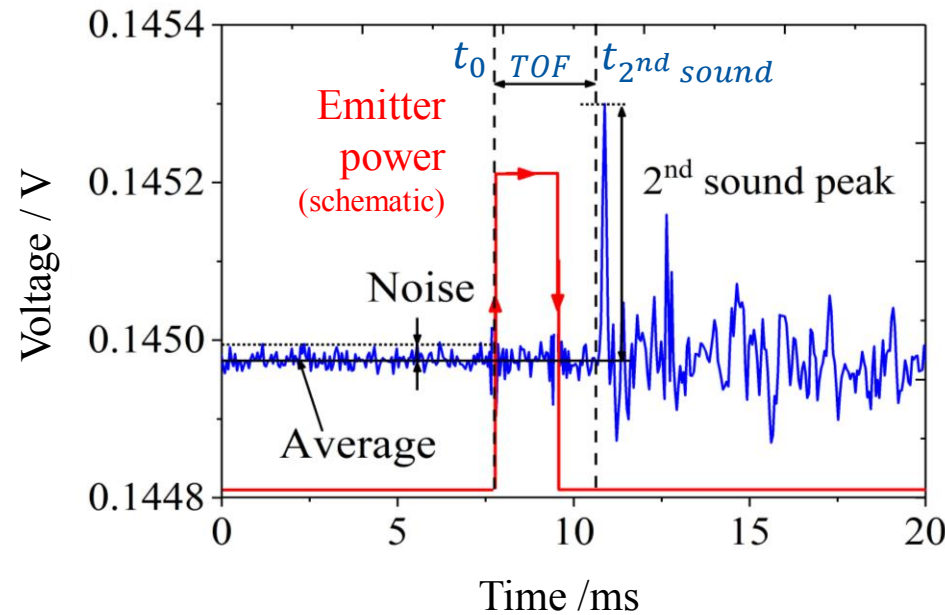
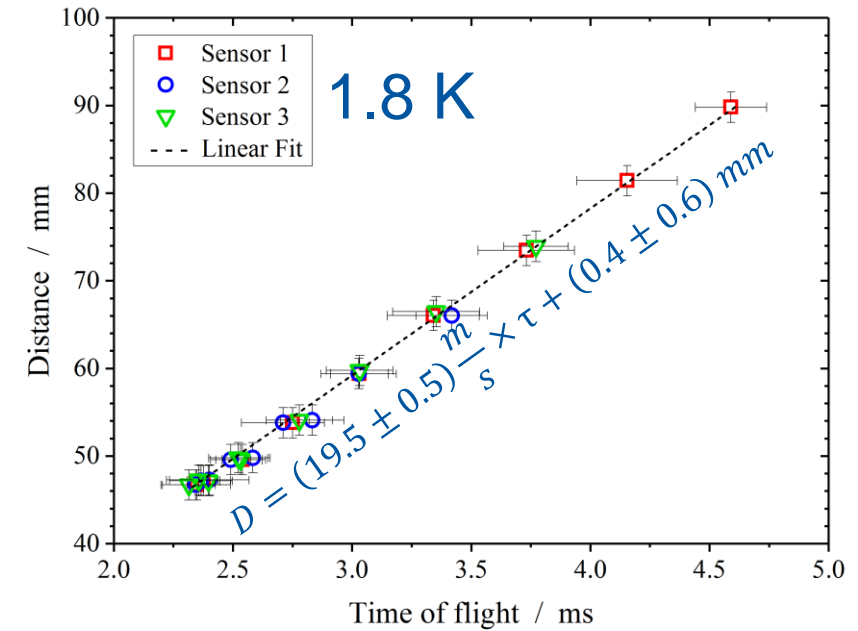
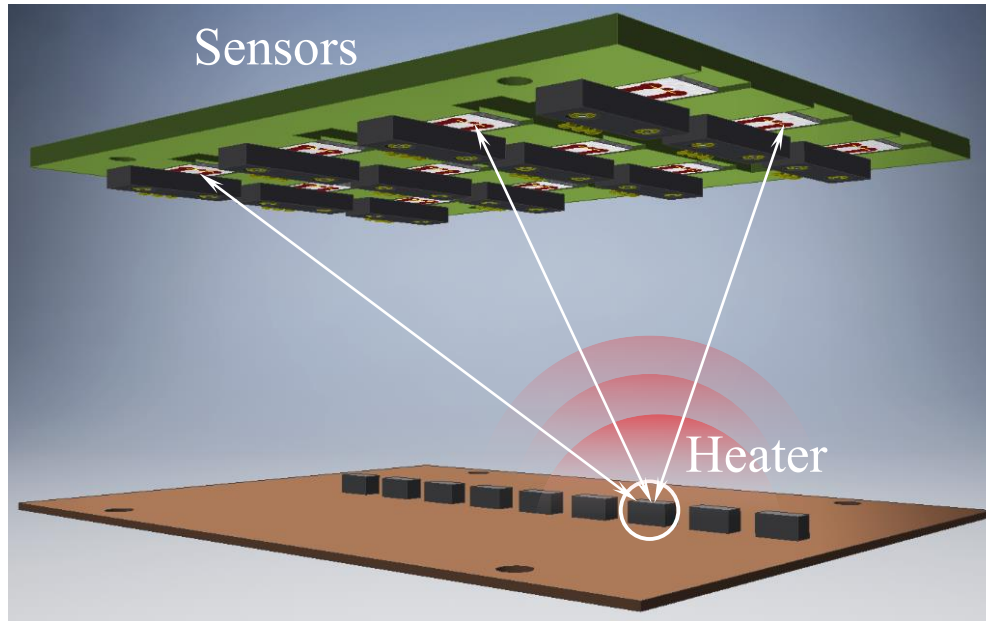
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Second sound speed

- Relative position of heat sources and sensors are known
- TOF of second sound is determined from measurement
- Second sound velocity was measured to **2% agreement** with values of 19.9 m/s in literature (Donnelly, J. Phys. Chem. Ref. Data, Vol. 27, No. 6, 1998).

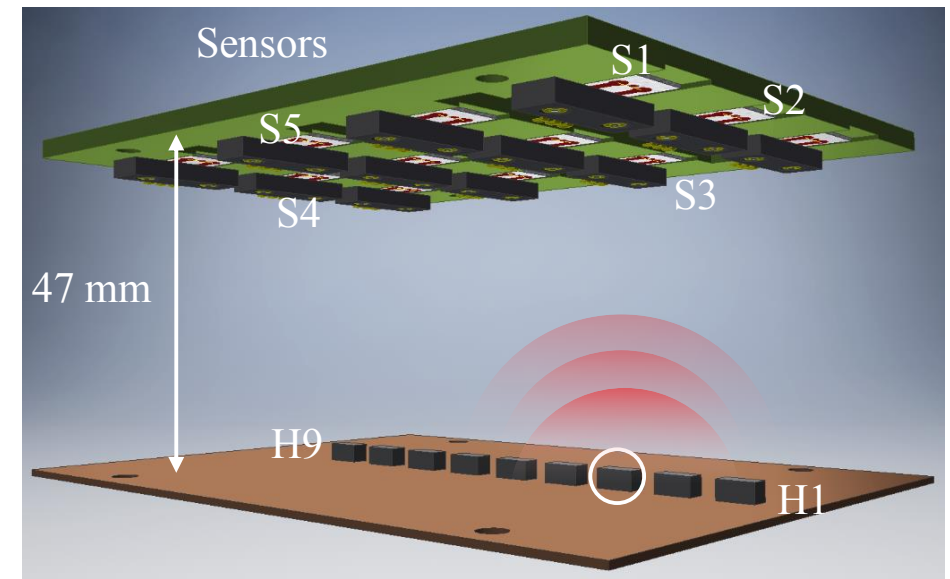


Localisation of small heat sources

Test at 2 K, with 5 sensors and 9 heaters (3 x 6 mm²)

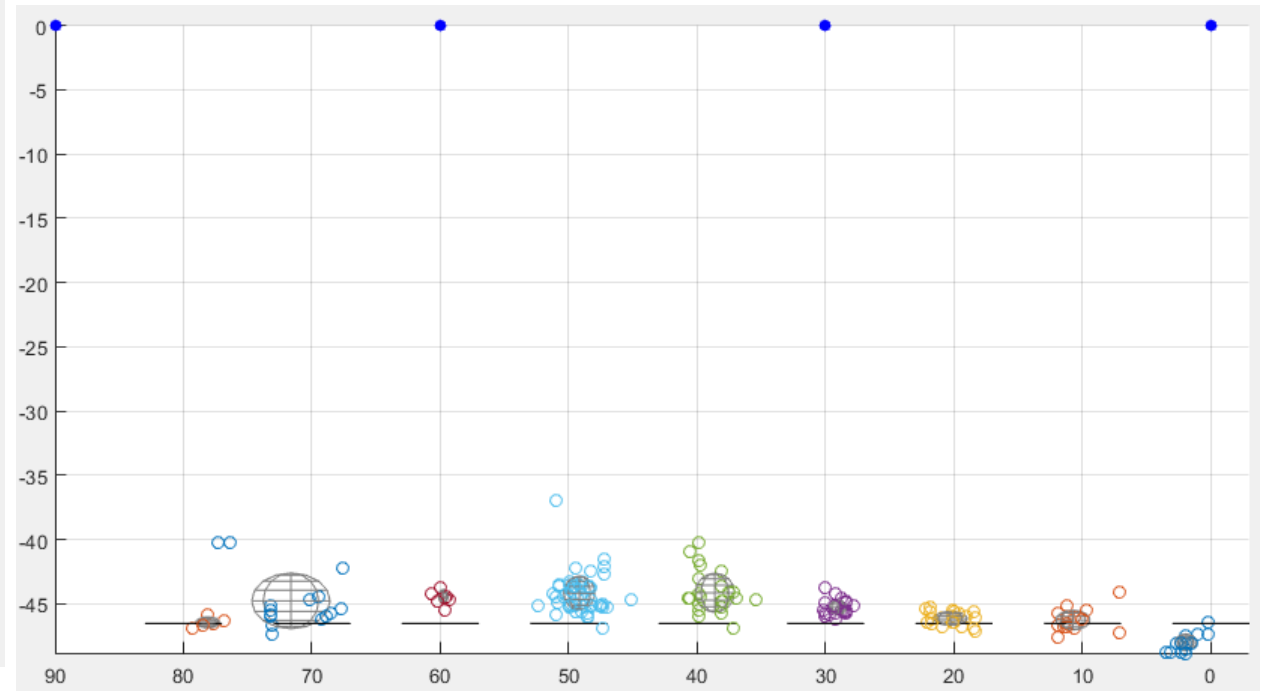
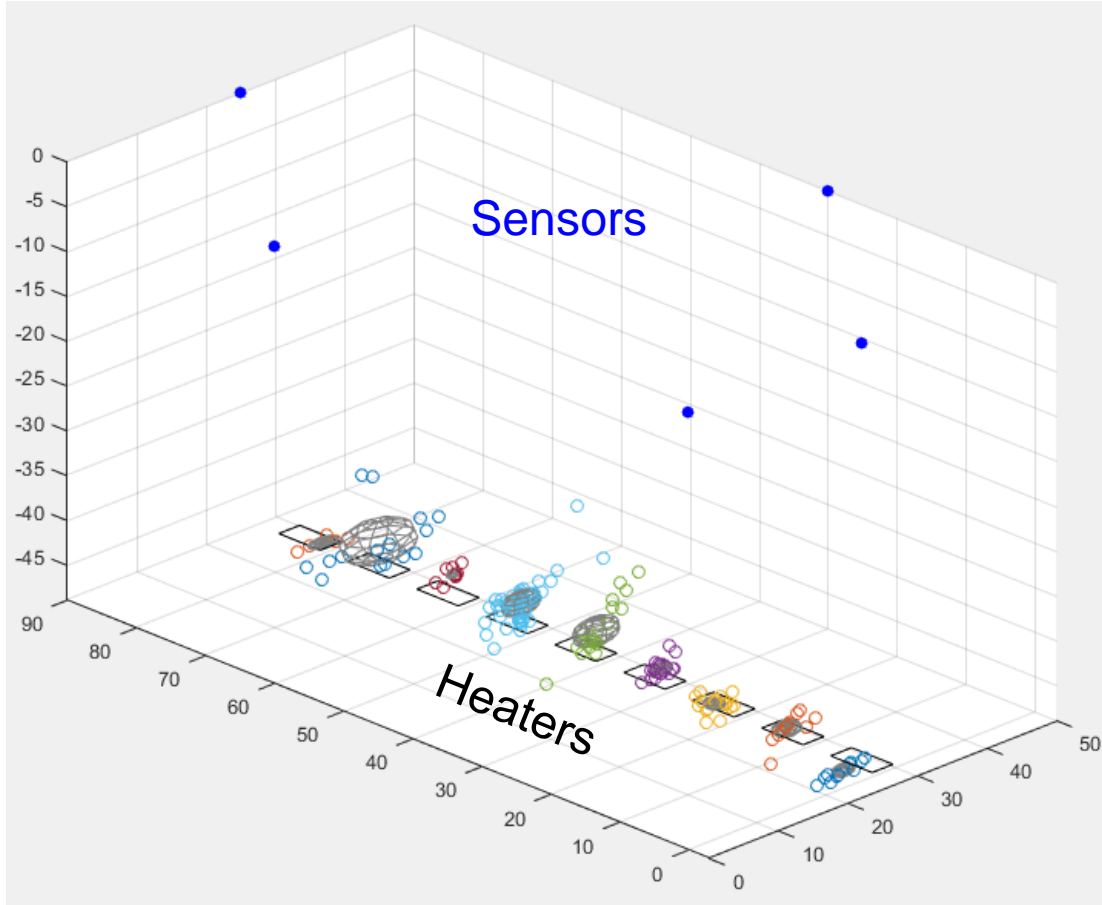
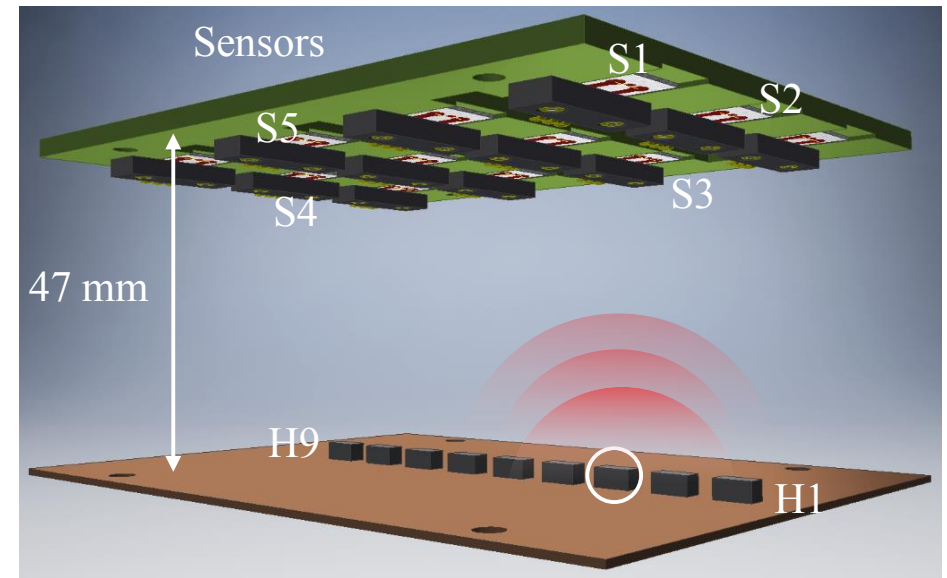
Second sound speed taken from literature, TOF measured

Application of trilateration algorithm (direct line of sight)



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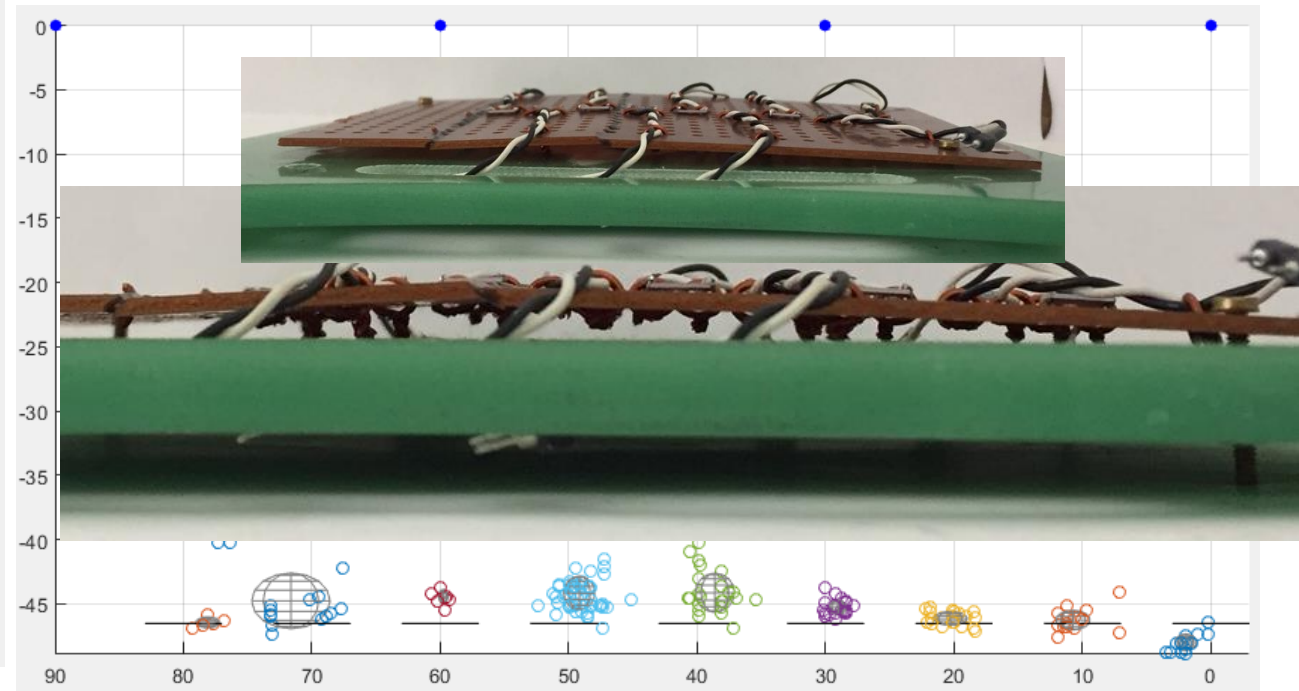
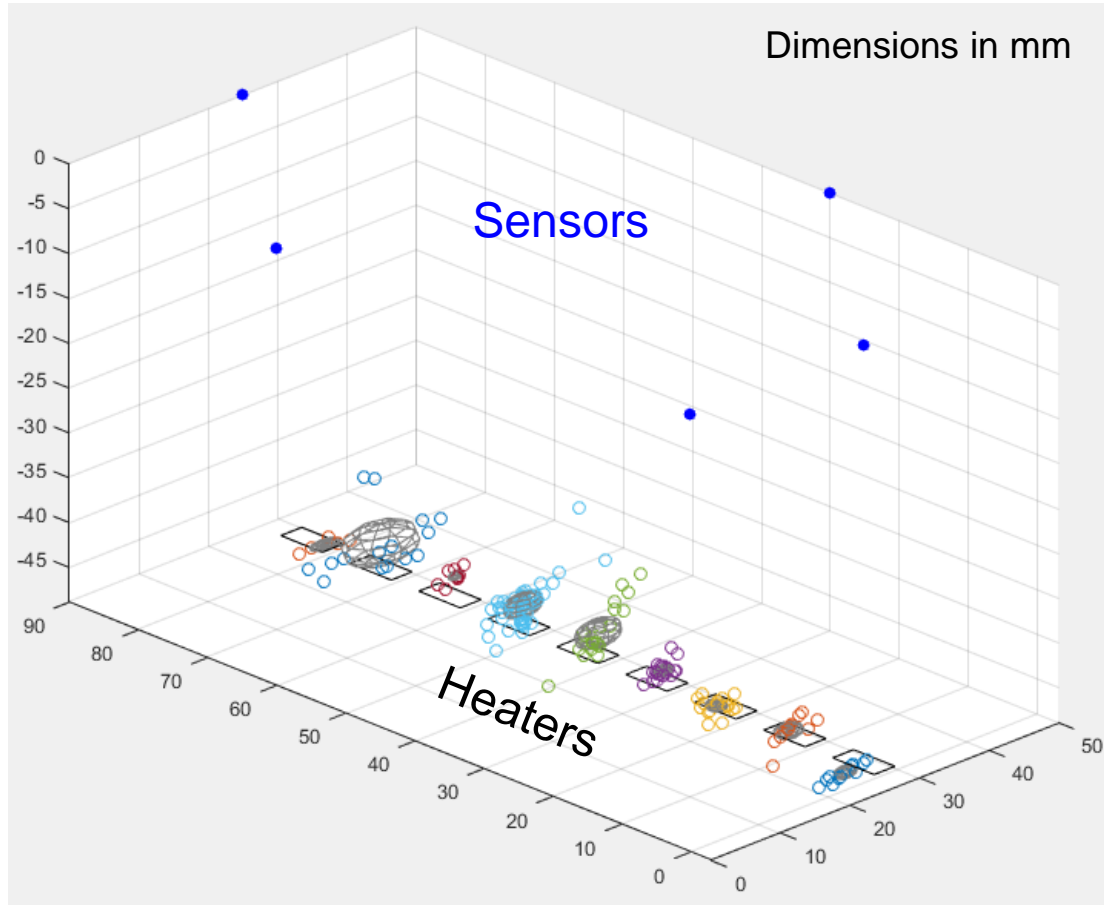
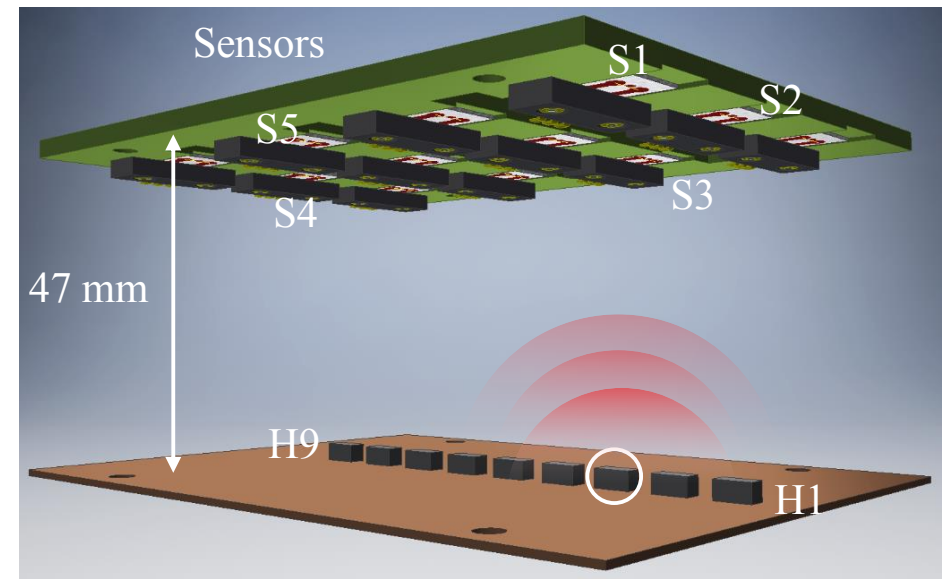


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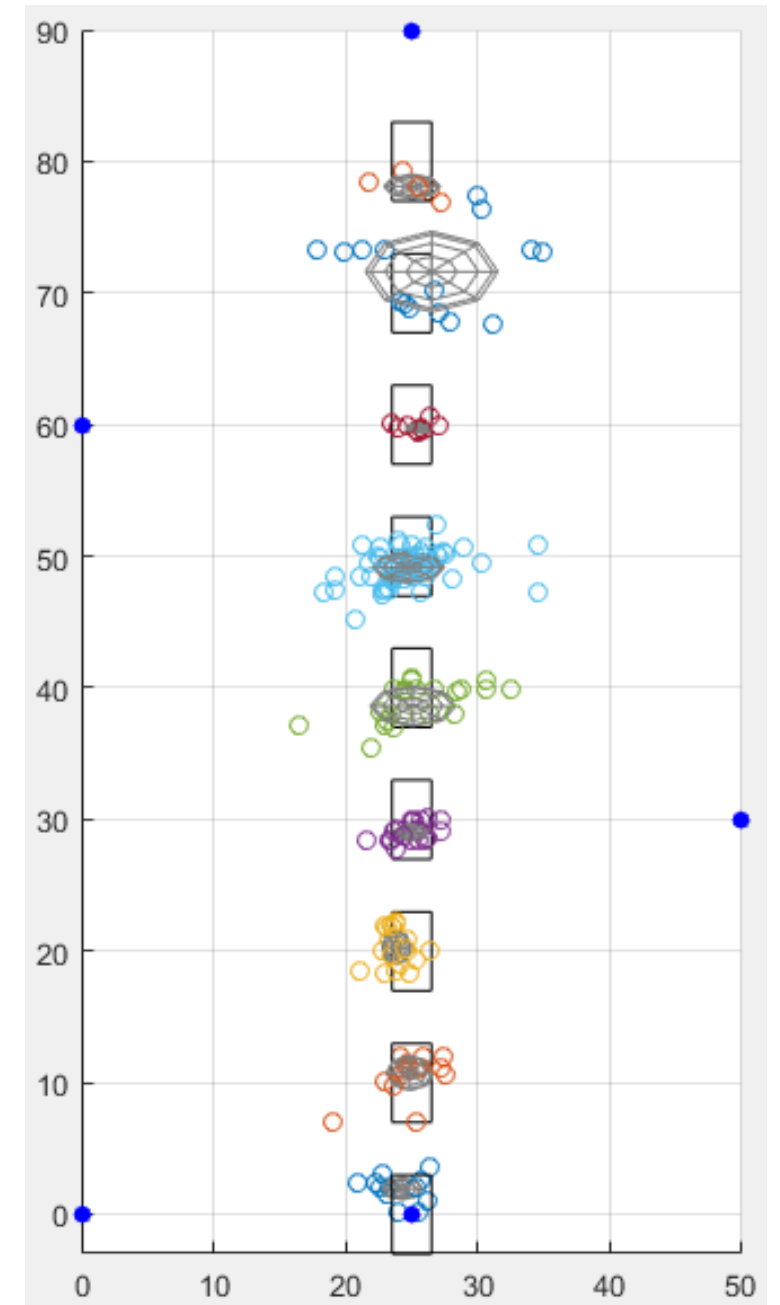
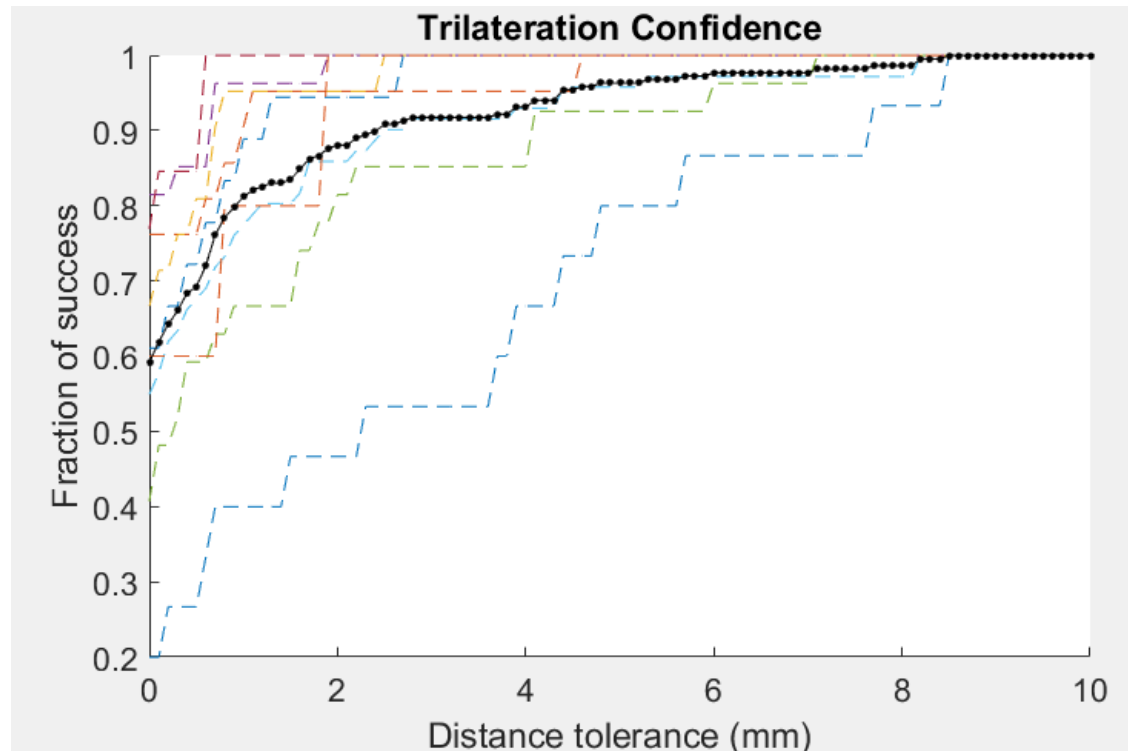
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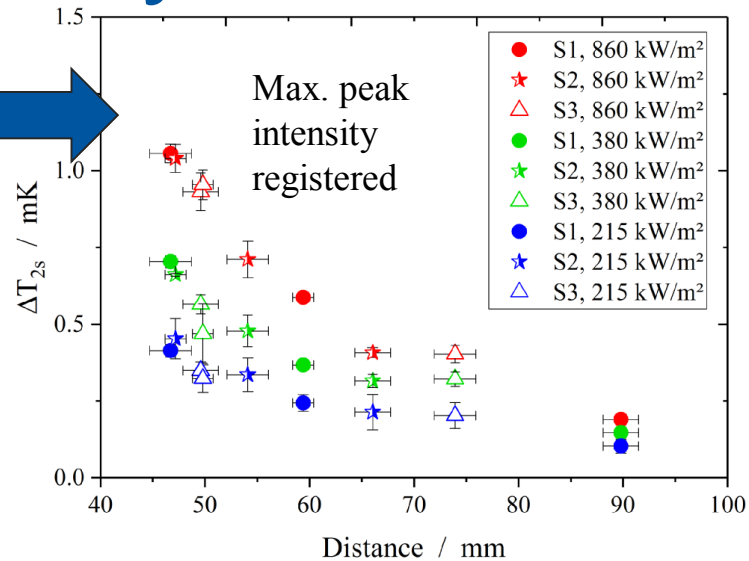
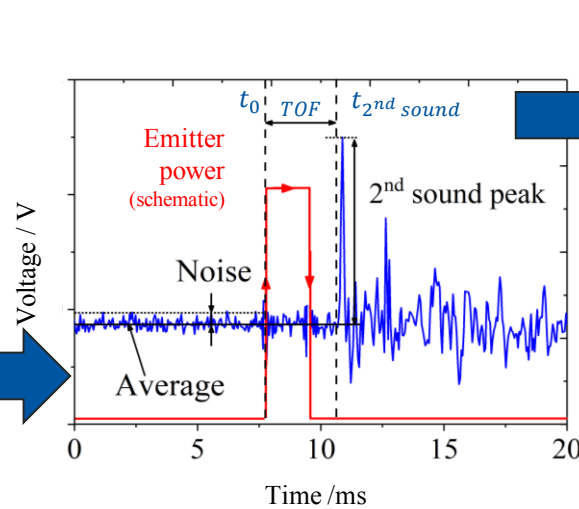
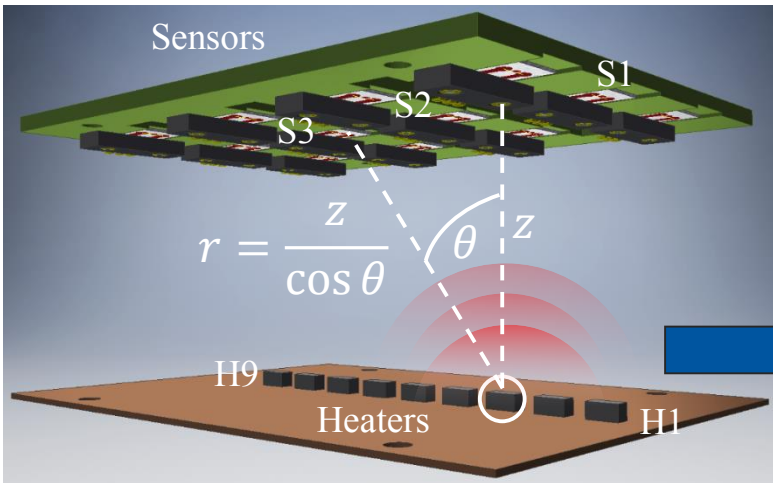
Application of trilateration algorithm (direct line of sight)

In more than 88 % of the cases, within 2 mm precision!

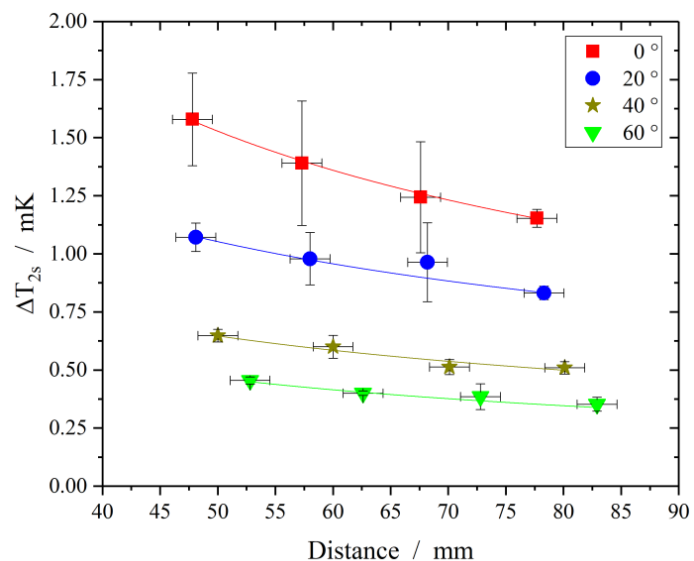
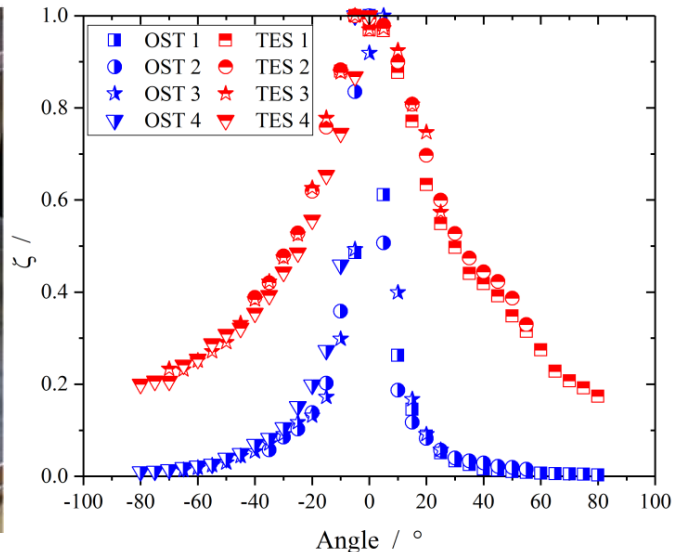
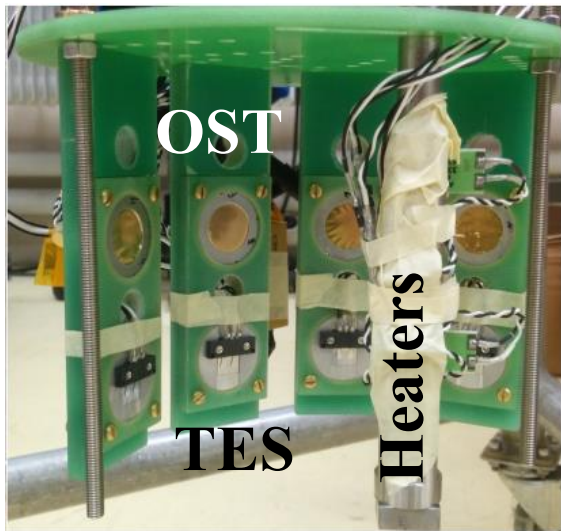
Uncertainty dominated by positioning and algorithm limitations
(but not by the sensor)



Second sound intensity distribution

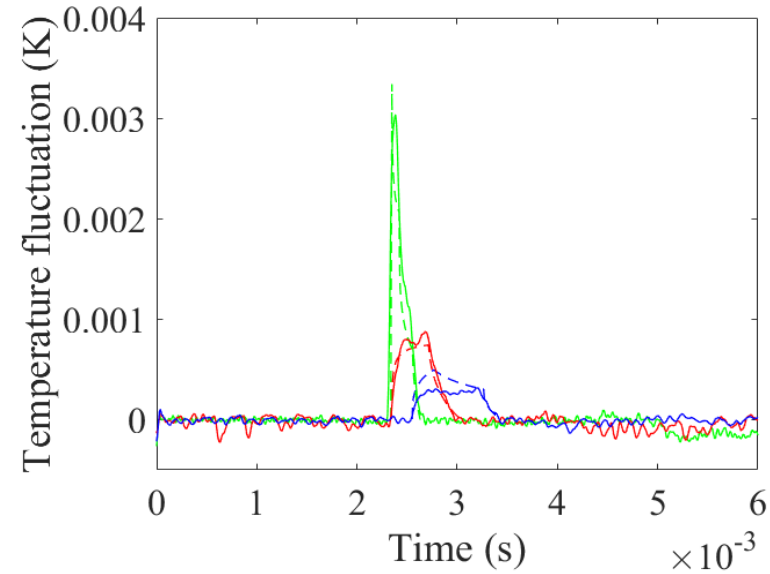
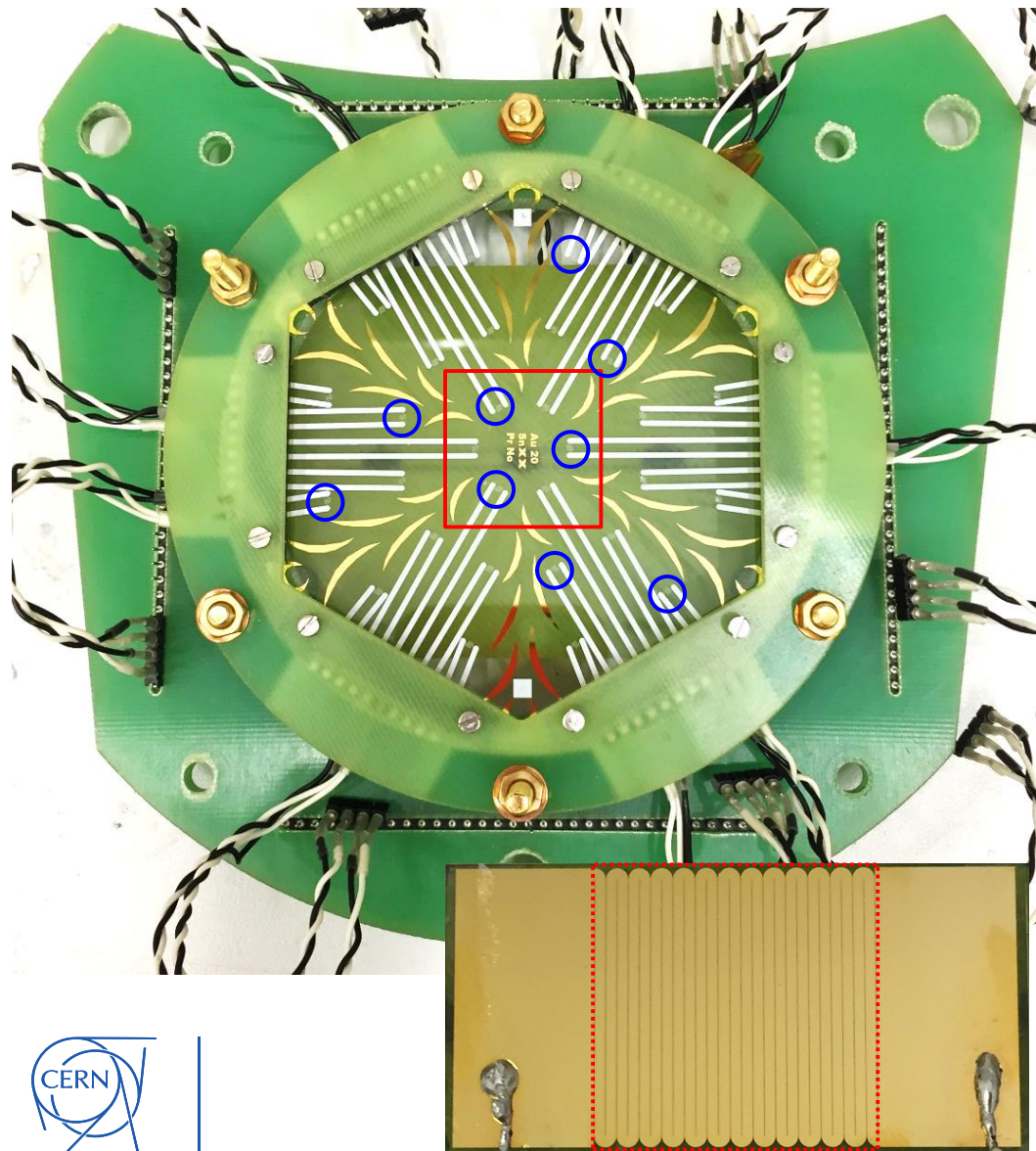


$\frac{\partial^2 T}{\partial t^2} - c^2 \nabla^2 T = 0$
The wave equation with spherical symmetry gives solutions of type $T = \frac{1}{r} f(r - ct)$ with f depending on B.C.
Experiment $\rightarrow T = Kr^{-n}$ with $n \approx 2.5 \pm 0.2$

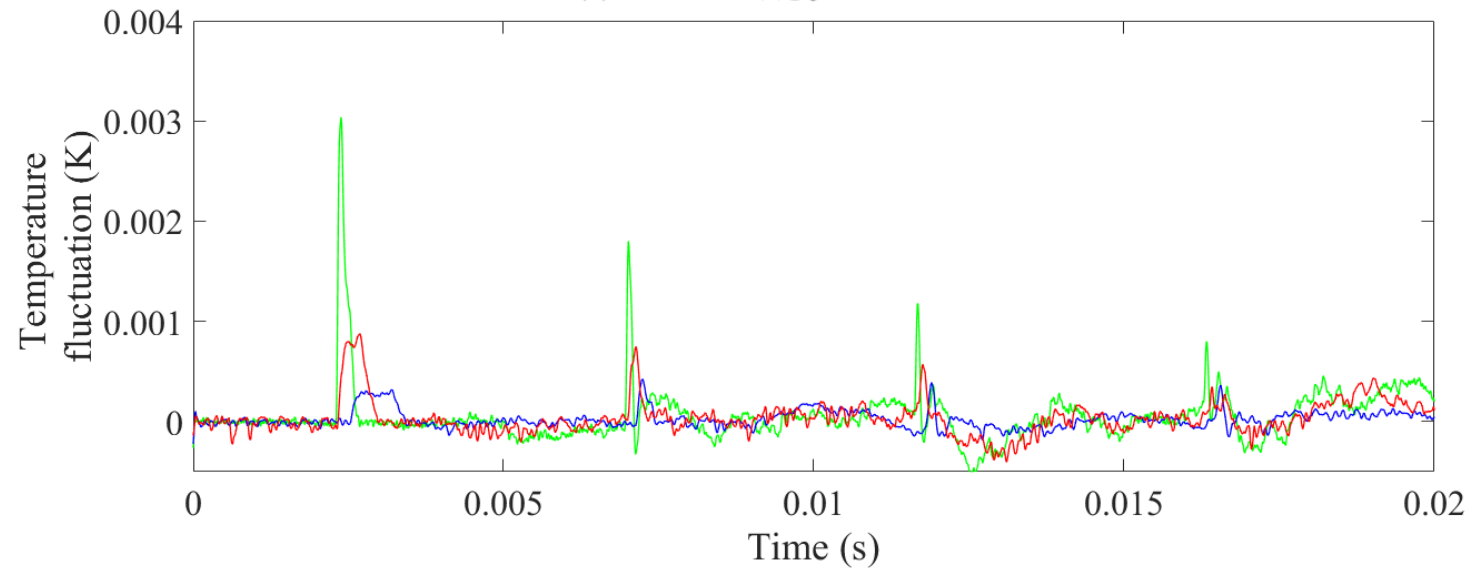


For more, come and see POSTERS E-06: 165 and 166

Experiments with extended heat sources



Different pulse shape and amplitude depending on relative position to heater. Predicted by modelling. For more, come to see posters E-06: 165 and 166



To summarize...

He-II Second sound detectors based on TES thermometry have been designed, prototyped and optimised.

- On-single-wafer Camera-like
- Individual chips

Alternative fabrication processes have been elaborated, tested and tuned.

- Evaporation Lift-off
- Sputtering Lift-off
- Sputtering IBE

TES were validated as a hotspot localisation tool through small scale experiments at the lab.

They also proved their capability as a tool for more fundamental studies.

- Second sound physics

Further development is ongoing

- Improvement of thermal response.
- Characterisation and optimization of the fabrication process.
- Production.



Giovanna Vandoni

- BE-RF
- Senior Scientist
- SRF activities coordinator



Torsten Koettig

- TE-CRG-CI
- Senior Cryogenics Scientist
- Cryolab R&D Coordinator



Hernán Furci

- BE-RF-SRF
- Senior Fellow
- Cryogenics Scientist
- R&D project responsible



Mentors



Tobias Stegmaier

- Masters thesis on Cryogenic experimental techniques for SRF



Zsolt Kovács

- Bachelor in Material Science with thesis in TES thin films



Ece Özelci

- Master in Mechanical Engineering developing ultra-fast response TES through microfabrication



Undergraduate students

Project started in March 2016

Acknowledgments

Cryolab

Technicians
Collaboration

Infrastructure
Helium

G. Rosaz, A. Mapelli, CMi of EPFL

Microfabrication
techniques

Thin films
expertise

A. Lunt, J. Busom Descarrega,
F. Leaux

Microscopic analysis

SEM, SESI, ESB, EDX,
FIB, etc.

A. Rijllart, E. Michel, P. Fernandez Lopez

DAQ advice

LabVIEW support

Do not miss the sequel! Oral E-14:163

Superconducting cavities quench localisation by He-II second sound detection with transition edge sensors

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M. Wartak, A. Zwozniak

ICEC 2018 – Oxford, UK – September 2018

